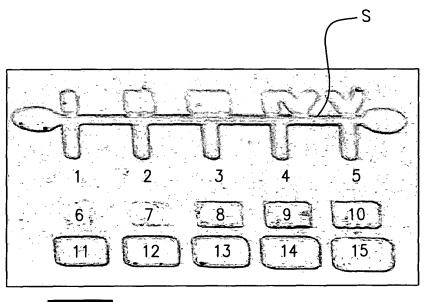


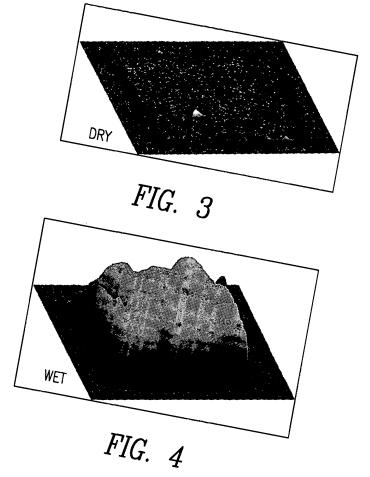
10 µm

FIG. 1



10 µm

FIG. 2



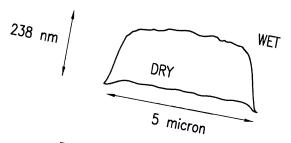


FIG. 5

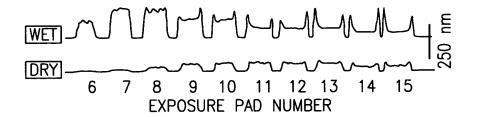


FIG. 6

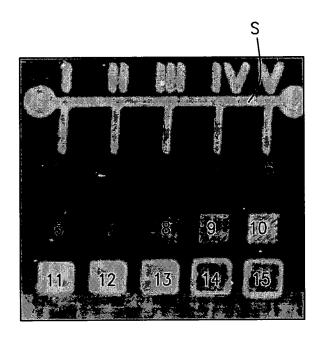


FIG. 7

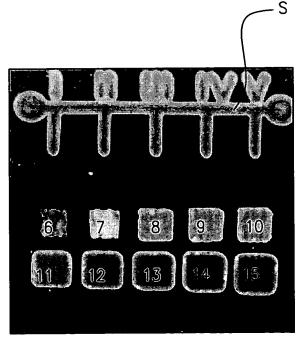


FIG. 8

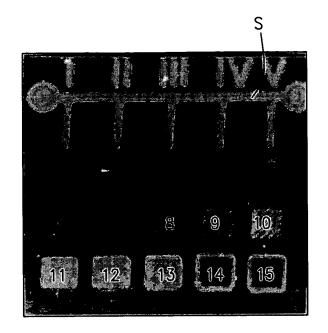


FIG. 7

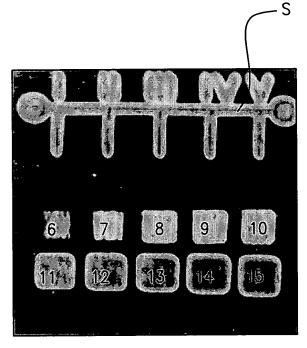


FIG. 8

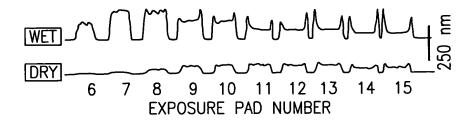
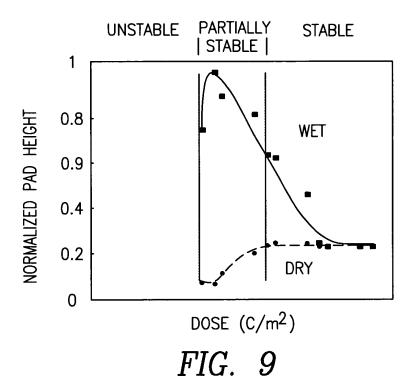


FIG. 9



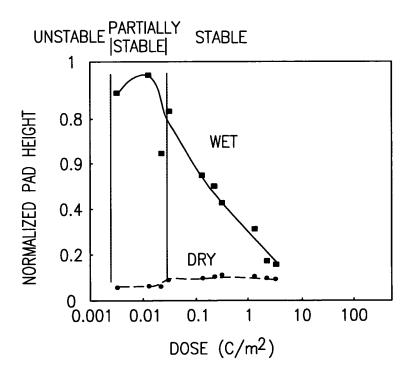


FIG. 10

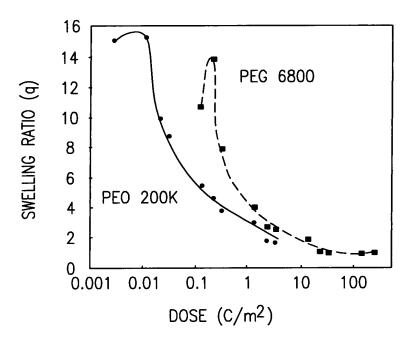


FIG. 11

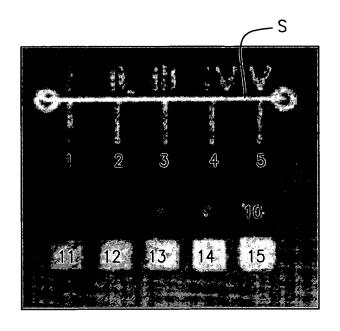


FIG. 12

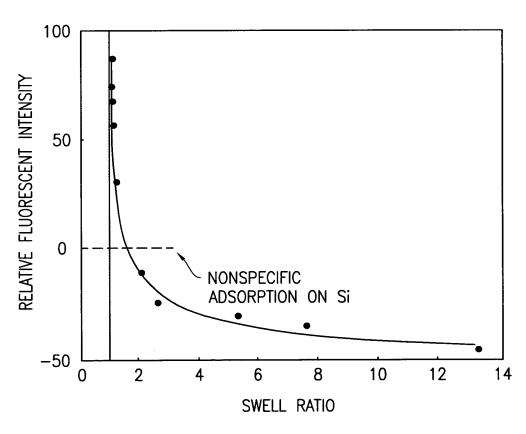


FIG. 13

FIG. 14

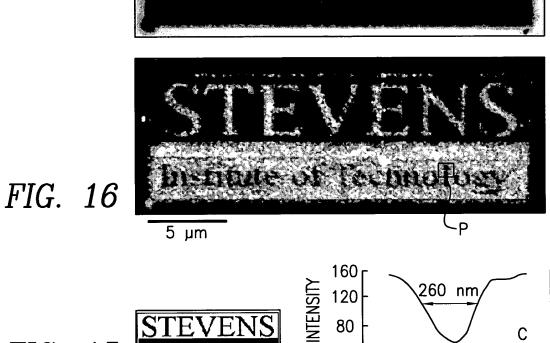


FIG. 15 Institute of Technology

| STEVENS | 120 | 260 nm | C | |

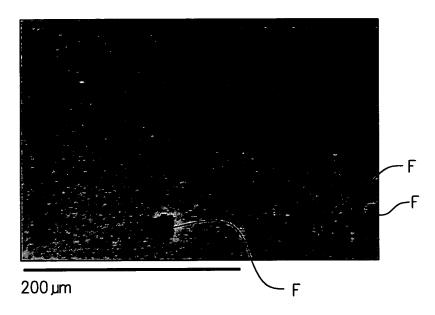
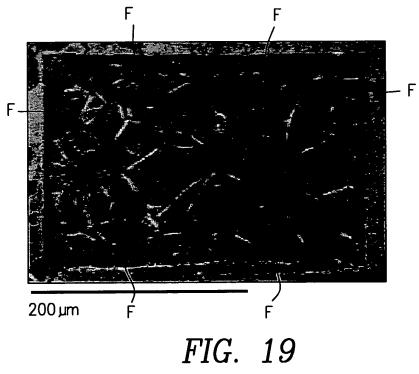


FIG. 18



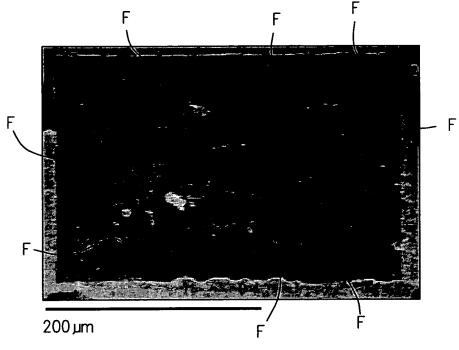


FIG. 20

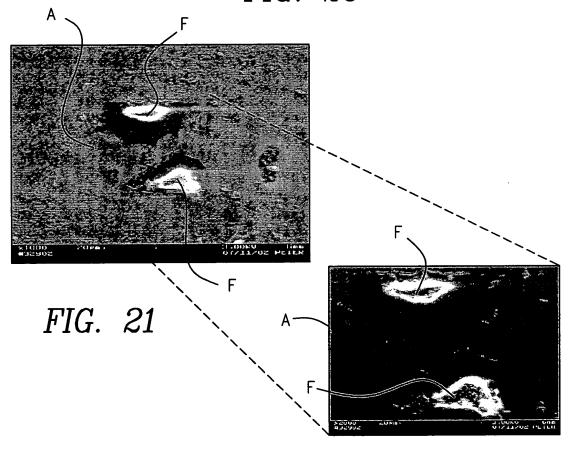
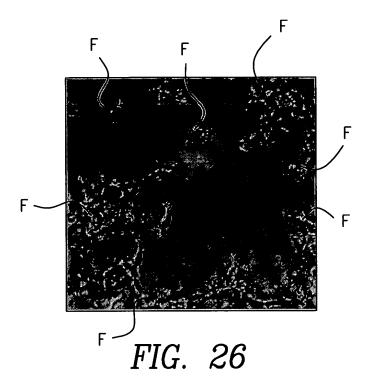
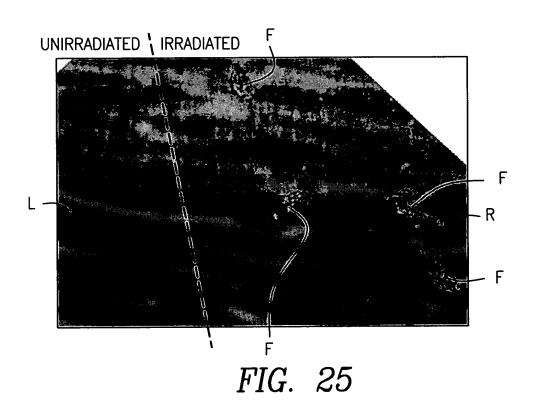


FIG. 22





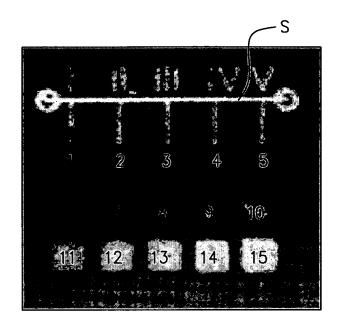


FIG. 12

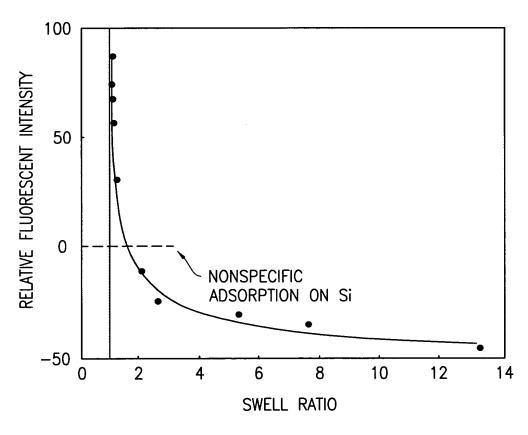
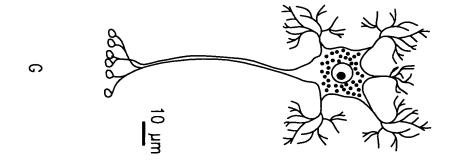


FIG. 13



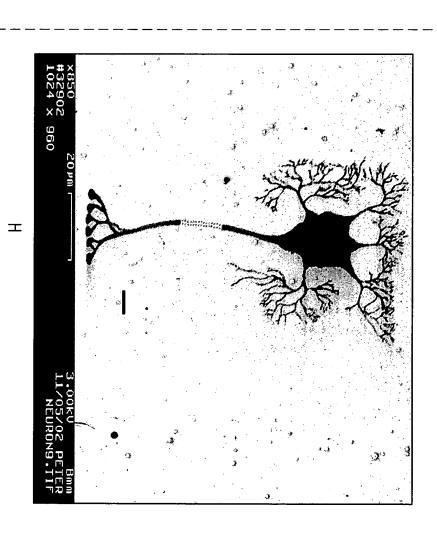


FIG. 31

